



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:** Pan et al.

**Serial No.:** 09/614,113

**Filed:** July 12, 2000

**For:** METHODS OF FORMING A GATE  
STACK THAT IS VOID OF SILICON  
CLUSTERS WITHIN A METALLIC SILICIDE  
FILM THEREOF (AS AMENDED)

**Confirmation No.:** 1710

**Examiner:** D. Deo

**Group Art Unit:** 1765

**Attorney Docket No.:** 2269-2915.3US  
(96-0149.02/US)

**CERTIFICATE OF MAILING**

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July 16, 2004  
Date

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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application, and with all continuing and divisional applications hereof:

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